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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(s): Sven Hansen

SERIAL NO.: 10/767,124

ART UNIT: 2851

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EXAMINER: Nelson,  
Vivian Hsu

TITLE: METHOD AND DEVICE FOR ADJUSTING AN ALIGNMENT  
MICROSCOPE BY MEANS OF A REFLECTIVE ALIGNMENT  
MASK

ATTORNEY

DOCKET NO.: 873-011675-US (PAR)

Mail Stop Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

I. INTRODUCTION

This is in response to the Office Action mailed July 18, 2005 (Paper No./Mail Date 20050707) in regard to the above-identified patent application. Reconsideration of the rejection of the claims is respectfully solicited in light of the following amendment and remarks.

Please amend the Application as follows: